IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hameed A. NASEEM et al.

Appln. No.:

Filed: Herewith

For: METHOD OF DOPING SILICON, METAL DOPED SILICON, METHOD OF MAKING SOLAR CELLS AND SOLAR CELLS

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified patent application as indicated below.

IN THE SPECIFICATION:

Page 1:

Please insert the following section after the title of the invention.